

033082 M 275



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Kazuhide Hasebe, et al.

Serial No.: 10/552,262

Art Unit: Not Yet Assigned

Filed: October 5, 2005

Examiner: Not Yet Assigned

For: SILICON DIOXIDE FILM REMOVING METHOD AND  
PROCESSING SYSTEM

THIRD INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the attached Chinese Office Action dated May 18, 2007. U.S. Patent Nos. 5,380,399 and 5,282,925 were previously cited in Information Disclosure Statements dated October 5, 2005. U.S. Patent No. 5,282,925 corresponds to CN 1088272 which is cited herewith.

Each item of information contained in this Information Disclosure Statement (PTO-1449) was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,  
SMITH, GAMBRELL & RUSSELL, LLP

By:

  
Michael A. Makuch, Reg. No. 32,263  
1850 M Street, N.W., Suite 800  
Washington, D.C. 20036  
Telephone: (202) 659-2811  
Fax: (202) 263-4329

July 13, 2007



FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT		ATTY. DOCKET 033082 M 275	SERIAL NO. 10/552,262
		APPLICANT: Kazuhide Hasebe, et al.	
		FILING DATE October 5, 2005	GROUP ART UNIT 1765

#### U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

#### FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	YES	NO
	AL	1088272	6/22/94	China					x
	AM								
	AN								
	AO								
	AP								

#### OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	English translation of Chinese Office Action dated May 18, 2007 issued in connection with CN Application No. 2004800110434
AR	
AS	
EXAMINER:	DATE CONSIDERED:

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.